

<b>Notice of References Cited</b>			Application/Control No.	Applicant(s)/Patent Under Reexamination KEEFER ET AL.	
			Examiner Maribel Medina	Art Unit 1754	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4,994,331	02-1991	Cohen, Ronald	429/17
	B	US-5,245,110	09-1993	Van Dijk et al.	585/733
	C	US-2002/0004157	01-2002	Keefer et al.	429/34
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 10027621 A	01-1998	Japan	KOGA, MINORU	H01M 08/06
	O	JP 04206161 A	07-1992	Japan	YANAGI, MASAAKI	H01M 08/06
	P	JP 63228572 A	09-1988	Japan	NAKAOKA et al.	H01M 08/06
	Q	WO 9919249 A1	04-1999	World Intellect	DE JONG et al.	C01B 03/00
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.